

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application.

Listing of Claims:

1. (Currently Amended) A method of manufacturing a plasma display panel in which the plasma display panel is held by a substrate holder for deposition, wherein the substrate holder is configured with a plurality of frames, the substrate is held by its periphery with at least one of the frames, the substrate having a bottom surface, a top surface opposite the bottom surface and a side surface extending from the bottom surface to the top surface, and the frame holding the substrate has a protrusion extending from the bottom surface of the substrate along the side surface of the substrate to a height greater than a height of the substrate without being superimposed over the top surface of the substrate;~~to a non-deposition face of the substrate held in such a way as to surround the substrate.~~

2. (Currently Amended) The method of manufacturing a plasma display panel as defined in Claim 1, wherein a height of the protrusion is between 1 mm and 100 mm ~~from the non-deposition face of the substrate.~~

3. (Original) The method of manufacturing a plasma display panel as defined in Claim 1, the frame comprising holding means including support means for supporting the substrate from underneath and positioning means for positioning the substrate in a planar direction, wherein the substrate is held by fitting the substrate to the positioning means and placing the substrate on the support means.

4. (Currently Amended) A substrate holder for a plasma display panel used for deposition on a substrate of the plasma display panel, the substrate holder being configured with a plurality of frames, the substrate being held by its periphery with at least one of the frames, the substrate having a bottom surface, a top surface opposite the bottom surface and a side surface extending from the top surface to the bottom surface, and the frame holding the substrate being provided with a protrusion extending from the bottom surface of the substrate along a side surface of the

~~substrate to a height greater than a height of the substrate without being superimposed over the top surface of the substrate; to a non-deposition face of the substrate held in such a way as to surround the substrate.~~

5. (Currently Amended) The substrate holder for a plasma display panel as defined in Claim 4, wherein a height of the protrusion is between 1 mm and 100 mm ~~from the non-deposition face of the substrate.~~

6. (Original) The substrate holder for a plasma display panel as defined in Claim 4, the frame comprising holding means including support means for supporting the substrate from underneath and positioning means for positioning the substrate in a planar direction, wherein the substrate is held by fitting the substrate to the positioning means and placing the substrate on the support means.